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OFFICE OF PETITIONS

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In re Application of
Rusch, et al.
Application No. 09/685,361
Filed: October 10, 2000
Atty. Dkt. No.: GR 98 P 1507
Title: METHOD OF MAKING A
SEMICONDUCTOR DEVICE

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: DECISION GRANTING STATUS
: UNDER 37 CFR 1.47(a)
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This decision is in response to the petition under 37 CFR 1.47(a), filed May 9, 2001.

Petitioner has shown that inventor Yoichi Otani has refused to join in the filing of the above-identified application after having been presented with the application papers.

The above-identified application and papers have been reviewed and found in compliance with 37 CFR 1.47(a). This application is hereby accorded Rule 1.47(a) status.

As provided in Rule 1.47(c), this Office will forward notice of this application's filing to the non-signing inventor at the address given in the petition. Notice of the filing of this application will also be published in the Official Gazette.

After this decision is mailed, the above-identified application will be returned to the Office of Initial Patent Examination for further processing.

Telephone inquiries related to this decision may be directed to the undersigned at (703) 305-0310.

Alesia M. Brown
Petitions Attorney
Office of Petitions
Office of the Deputy Commissioner
for Patent Examination Policy